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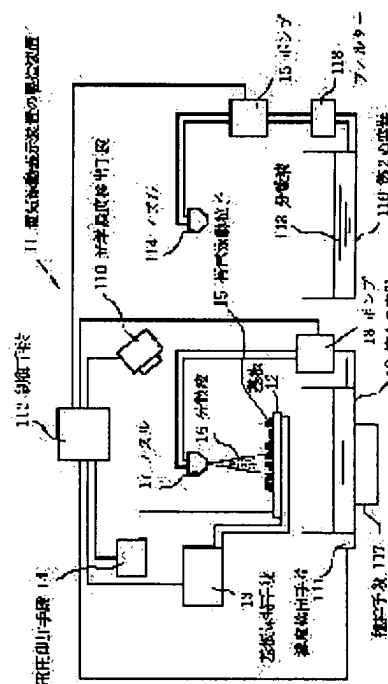
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(54) DEVICE FOR MANUFACTURING ELECTROPHORESIS DISPLAY DEVICE

(57)Abstract:

PROBLEM TO BE SOLVED: To provide a device for manufacturing a high-definition electrophoresis display device which can easily and uniformly dispose charged migration particles in a dispersed liquid in each display element even when a gap between two substrates is very small and a flexible substrate or the like is used.

SOLUTION: The device is intended for manufacturing the electrophoresis display device having the charged migration particles, a dispersion medium in which the charged migration particles are distributed, and a substrate on which an electrode is formed. The manufacturing device has a substrate holding means 13 holding the substrate 12, a means 14 to apply voltage to the electrode formed on the substrate 12, and a means to inject a dispersed liquid 16 in which the charged migration particles are distributed to the electrode for depositing the charged migration particles 15 on the electrode.



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